



#### PATENT APPLICATION

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q80874

Hiromoto OHNO, et al.

Appln. No.: 10/591,119

Group Art Unit: 1621

Confirmation No.: 7742

Examiner: Sikarl A. Witherspoon

Filed: August 30, 2006

For: PROCESS FOR PRODUCTION OF 1,1,1,2- TETRAFLUOROETHANE AND/OR

PENTAFLUOROETHANE AND APPLICATIONS OF THE SAME

#### REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

**ATTN:** Office of Initial Patent Examination

Filing Receipt Correction

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

We enclose a copy of the Corrected Official Filing Receipt for the above-identified application and request the following correction(s):

After Title: Please delete: PROCESS FOR PRODUCTION OF 1,1,1,2-TETRAFLUOROETHANE AND/OR PENTAFLUORETHANE AND APPLICATIONS OF THE SAME

**Please insert:** PROCESS FOR PRODUCTION OF 1,1,1,2- TETRAFLUOROETHANE AND/OR PENTAFLUOROETHANE AND APPLICATIONS OF THE SAME

# CORRECTED OFFICIAL FILING RECEIPT REQUEST

U.S. Appln. No.: 10/591,119

Attorney Docket No.: Q80874

Verification for the requested correction(s) is indicated on the Declaration filed August 30, 2006.

Respectfully submitted,

Registration No. 33,725

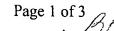
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WASHINGTON OFFICE

23373
CUSTOMER NUMBER

Date: September 21, 2007





### United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address COMMISSIONER FOR PATENTS P.O. BOX 1450 Alexandria, Virginia 22313-1450

SEP 2 1 2007

	FILING OR 371(c)				T	
APPL NO.	DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	TOT CLMS	IND CLMS
10/591,119	08/30/2006	1621	900	Q80874	13	1

23373 SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037 CONFIRMATION NO. 7742
CORRECTED FILING RECEIPT
\*OC000000025122370\*

Date Mailed: 08/01/2007

Receipt is acknowledged of this nonprovisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

#### Applicant(s)

Hiromoto Ohno, Kanagawa, JAPAN; Toshio Ohi, Tokyo, JAPAN;

#### **Assignment For Published Patent Application**

SHOWA DENKO K.K.

Power of Attorney: The patent practitioners associated with Customer Number 23373.

### Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP05/06521 03/28/2005 which claims benefit of 60/559.428 04/06/2004

#### Foreign Applications

JAPAN 2004-095012 03/29/2004

If Required, Foreign Filing License Granted: 05/09/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is US10/591,119

Projected Publication Date: 08/16/2007

Non-Publication Request: No

Early Publication Request: No

Title

Process for production of 1,1,1,2- tetrafluoroethane and/or pentafluorethane and applications of the same

Pentafluoro ethane

**Preliminary Class** 

570

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Title 37, Code of Federal Regulations, 5.11 & 5.15

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